

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Kun Li et al.
Serial No.: 10/523,777
Filed: August 28, 2003
Art Unit: 2825
Confirmation No.: 5732
Examiner: Steven R. Garland
Title: **METHOD AND SYSTEM FOR DYNAMIC MODELING AND
RECIPE OPTIMIZATION OF SEMICONDUCTOR ETCH
PROCESSES**
Atty. Docket: VOY-007US

Cincinnati, Ohio

November 14, 2006

VIA ELECTRONIC TRANSMISSION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

ISSUE FEE
CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence for Application No. 10/523,777 is being electronically transmitted to Technology Center 3733, via EFS-WEB, on November 14, 2006.

By /Joseph R. Jordan/
Joseph R. Jordan
Reg. No. 25,686

November 14, 2006
Date

Wood, Herron & Evans, L.L.P.
2700 Carew Tower
441 Vine Street
Cincinnati, Ohio 45202
(513) 241-2324 - Voice
(513) 421-7269 - Facsimile